

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Song et al.

Serial No.: 10/720,966

Filed: November 24, 2003

For: **PHOTORESIST COMPOSITION  
AND METHOD PATTERN  
FORMING USING THE SAME**

)  
)  
) Group Art Unit: 1752

)  
) Examiner: John S. Y. Chu

)  
) Confirmation No.: 5221

)  
) TKHR Docket: 250913-1030

) Top-Team: 0424-8857US  
)

RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

The FINAL Office Action mailed November 14, 2006, has been carefully considered. In response thereto, Applicants hereby submit following remarks and the accompanying petition for a 2-month extension of time. Reconsideration and allowance of the application and presently pending claims, as amended, are respectfully requested.

*No amendment.*  
*OK to enter remarks.*  
*jsa*  
*4/2017*